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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Richard P. Torti, et al.

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For: CLUSTER SIZE MEASUREMENT INSTRUMENT AND METHOD FOR CLUSTER
ION BEAM DIAGNOSTIC

PERKINS, SMITH & COHEN, LLP
One Beacon Street
Boston, MA 02108
(617) 854-4000

To: Assistant Commissioner of Patents
Washington D.C. 20231-0001

INFORMATION DISCLOSURE STATEMENT

Sir:

This Information Disclosure Statement (Form PTO-1449) is submitted under 37 CFR 1.97(b) with the application and includes copies of cited references.

REMARKS

Applicant submits herewith this Information Disclosure Statement under 37 CFR 1.97(b). In view thereof, no fee is required, however, in the event fees are required please charge any underpayment of fees to or credit any overpayment of fees to Deposit Account No. 03-2410 Order No.: 11460-109.

The following information is presented in the event that a call may be deemed desirable by the Examiner:

JACOB N. ERLICH (617) 854-4000.

Respectfully submitted,

Richard P. Torti, et al., Applicants

Dated: March 19, 2001

By: Jacob N. Erlich

JACOB N. ERLICH, Reg. No. 24,338
Attorney for Applicants